



SHEET 1 OF 1

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2879**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

**U.S. PATENT APPLICATION PUBLICATIONS**

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**U.S. PATENT APPLICATIONS**

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**FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
S.R.	JP 2000-156166	6/6/2000	Japan (1 <sup>st</sup> page w/English Abstract)			X	
S.R.	JP 09-208851	8/12/1997	Japan (1 <sup>st</sup> page w/English Abstract)			X	
S.R.	JP 10-334809	12/18/1998	Japan (1 <sup>st</sup> page w/English Abstract)			X	
S.R.	JP 2004-047193	2/12/2004	Japan (1 <sup>st</sup> page w/English Abstract)			X	

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)**

Japanese Office Action dated December 16, 2005

EXAMINER

Sikha Roy

DATE CONSIDERED

2/8/06

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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